

FORM PTO-1449  
(Rev 8/83)U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

## INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Atty. Docket No.:	Appl'n No.:
ELG056-US	10/720,421
Applicant:	
Kent et al.	
Filing Date:	Group:
Nov. 24, 2003	2673

## US PATENT DOCUMENTS

* Exr. initial	Document number	Date	Name	Class	Sub-class	Filing date (if appropriate)
	4,680,430 A	07/14/1987	Yoshikawa et al.	178	19	
	4,687,885 A	08/18/1987	Talmage, Jr., et al.	178	18	
	5,250,388 A	10/05/1993	Schoch, Jr., et al.	430	269	
	5,892,244 A	04/06/1999	Tanaka et al.	257	40	
	6,204,515	03/20/2001	Bernius et al.	257	40	
	2001/043291 A1	11/22/2001	Kono et al.	349	12	
	6,596,569 B1	07/22/2003	Bao et al.	438	151	

## FOREIGN PATENT DOCUMENTS

* Exr. initial	Document number	Date	Country	Class	Sub-class	Translation enclosed (?)
	0 097 368 A	01/04/1984	Europe	G06K	11/06	

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

Exr. initial	Details of Document	Translation enclosed (?)
	International Search Report for International Application No. PCT/US2004/038348, dated July 21, 2005.	
	International Search Report for International Application No. PCT/US2004/038349, dated July 21, 2005.	
	Richard Friend et al., "Polymer Diodes", <u>Physics World</u> , Bristol, Great Britain, vol. 12, no. 6, June 1999, pages 35-40.	
	L.S. Roman et al., <u>Appl. Phys. Lett.</u> , vol. 75, 1999, pages 3557-3559.	
	G. Greczynski et al., <u>Thin Solid Films</u> , vol. 354, 1999, pages 129-135.	
	L.S. Roman et al., <u>Synth. Metals</u> , vol. 125, 2002, pages 419-422.	
	Patent Abstracts of Japan, vol. 008, no. 190 (E-263), 31 August 1984 & Japanese Publication No. JP 59-078584 A (Toshiba KK), 7 May 1984 (abstract only)	

Examiner's signature

Date considered

\* EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.